

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1005

Applicants : Yasuo KOBAYASHI, et al.
U.S. Serial No. : 10/568,461
Filed : February 15, 2006
Examiner : Reema PATEL
Group Art Unit : 2812
For : SEMICONDUCTOR DEVICE, METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE
AND GAS FOR PLASMA CVD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mail Stop: Amendment

Sir:

In response to the Office Action mailed on December 26, 2007, please amend the above-identified application as set forth below and consider the following remarks.

This Amendment is accompanied by a Petition for Extension of Time (Three Months) to extend the due date for response to June 26, 2008, and a payment for the sum of \$1050 of the extension fee (\$1050) by credit card.

Amendment to the claims begin on page 2.

Remarks begin on page 5.